

Figure 1 The amounts of physical adsorptions according to partial pressures of (a) HF and (b)  $\text{CH}_3\text{OH}$ .

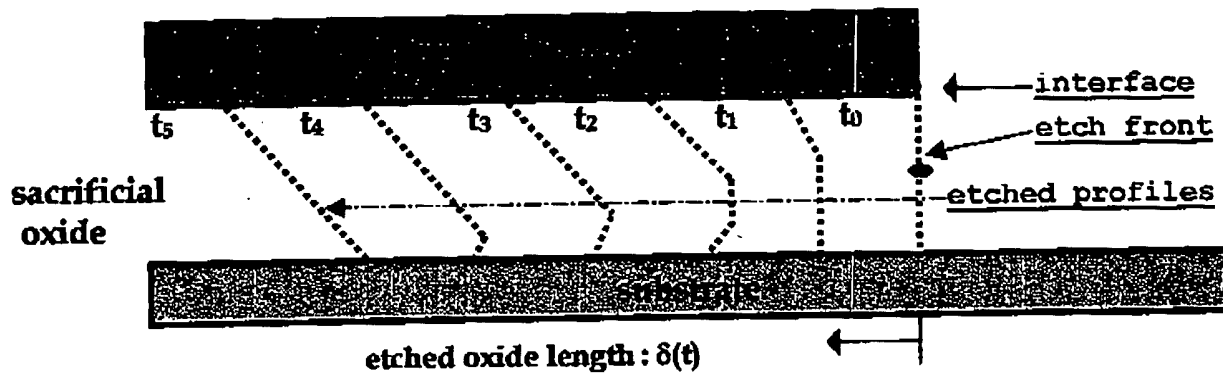


Figure 2. Schematic of etching mechanism to release microstructure.